

AF/IFW



Attorney Docket 0553-0393

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
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Shunpei Yamazaki et al.)
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Serial No.: 10/757,167)
)
Filed: January 13, 2004)
)
For: Method For Manufacturing Conductive) Layer And Semiconductor Device)
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Art Unit: 2822)
)
)
Examiner: Christy L. Novacek)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:
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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace
Signature

1/4/06
Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT (B) AFTER FINAL

Sir:

In response to the Final Rejection of October 5, 2005, please enter the following amendment
in the above-identified application: